



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Ali Shajii et al. Examiner: TBA
Serial No.: 10/669,065 Group Art Unit: 2855
Filing Date: September 23, 2003
Docket Number: 56231-417 (MKS-131)
Title: TWO PHASE FLOW SENSOR USING TOMOGRAPHY
TECHNIQUES

CERTIFICATE OF MAILING PURSUANT TO 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Mail Stop Missing Parts, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Date: 4/28/04

Gayle Endres
Gayle Endres

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER

Dear Sir:

Enclosed herewith for filing in connection with the above-identified patent application are the following:

- 1) Information Disclosure Statement;
- 2) Form PTO-A820 (also form 1449);
- 3) Copies of publications listed on Form PTO-1449; and
- 4) Acknowledgment Postcard.

Dated: April 28, 2004

Respectfully Submitted,

Elizabeth E. Kim

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

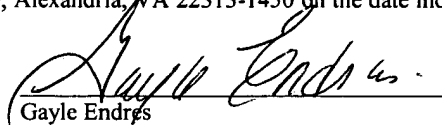
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Date:

4/28/04


Gayle Endres

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

Applicants and their attorney are aware of the following publications and information, listed on the attached Form PTO-A820, and in accordance with 37 CFR §1.97 hereby submit these publications for the Examiner's consideration. This Statement is being filed more than three months after the filing date of the application, but before the receipt of any Official Action from the Patent and Trademark Office. A full copy of each cited publication is enclosed.

This statement is not to be interpreted as a representation that the cited publications are material, that an exhaustive search has been conducted, or that no other relevant information exists. Nor shall the citation of any publications herein be construed *per se* as a representation that such publications are prior art. Moreover, the Applicants understand that the Examiner will make an independent evaluation of the cited publications.

U.S.S.N. 10/669,065

April 28, 2004

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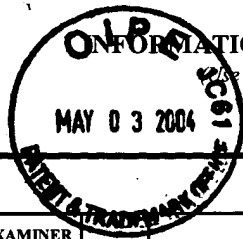
No additional costs are believed to be due in connection with the filing of this Information Disclosure Statement. If, however, a first Office Action on the merits issues in this application bearing a mailing date prior to the date of this Information Disclosure Statement, please charge any necessary fees to our Deposit Account No. 50-1133.

Respectfully submitted,

Elizabeth Kim

Date: 04-28-04

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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

56231-417 (MKS-131)

Application Number

10/669,065

Applicant(s)

Ali Shajii et al.

Filing Date

September 23, 2003

Group Art Unit

2855

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		Zhiyao Huang et al., "Application of Electrical Capacitance Tomography to the Void Fraction Measurement of Two-Phase Flow", <i>IEEE Transactions on Instrumentation and Measurement</i> , Vol. 52, No. 1, February 2003, pp. 7-12.
		Kjetil Ullaland, "The Design of a VLSI Mixed Analogue and Digital Modular ASIC Processor for Capacitance Tomography", October 1994, University of Bergen, Bergen, Norway, pp. 4.1 - 4.6.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.